

**AMENDMENTS TO THE SPECIFICATION**

Please amend the paragraphs starting on these lines as follows:

Page 6, line 23:

Preferred embodiments of this invention will be described hereinafter, referring to drawings. Fig. 1 illustrates a light diffusion sheet in which ~~an~~ a light diffusion layer 4 comprising a transparent resin layer 2 having fine particles 3 dispersed therein is formed on a transparent substrate 1. Fine particles 3 currently dispersed in the transparent resin layer 2 forms unevenness shape on the surface of the light diffusion layer 4. In addition, although Fig. 1 illustrates a case where the transparent resin layer 2 consists of one layer, an light diffusion layer may also be formed of two or more transparent resin layers by forming separately transparent resin layer including fine particles between the transparent resin layer 2 and the transparent substrate 1.

Page 9, line 19:

A forming method of the transparent resin layer 2 having fine unevenness structure surface is not especially limited so long as it is formed on the transparent substrate 1, but any proper methods may be adopted. For example, a method of forming fine unevenness structure on a surface of a material itself that forms the transparent resin layer 2 may be mentioned. As illustrative examples, a method may be mentioned in which rough surfacing processing is beforehand given to the surface of the film used for formation of the above described transparent

Amendment

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resin layer 2 by proper manners, such as sandblasting, roll embossing, and chemical etching to give fine unevenness structure to the film surface. And, a method may also be mentioned in which additional coating of another transparent resin layer 2 is separately given on the transparent resin layer 2, and fine unevenness structure is given by a transfer method with metal mold etc. onto the transparent resin layer surface concerned. Furthermore, as shown in ~~Figure 2~~Figure 1, fine unevenness structure is given by dispersing fine particles 3 in the transparent resin layer 2 may be mentioned. In the formation method of these fine unevenness structures, two or more kinds of methods may be used in combination, and a layer may be formed in which different type of fine unevenness structures are compounded on the surface. In the formation method of the above described resin coated 2, a method of forming a transparent resin layer 2 that contains the fine particles 3 dispersed therein is preferable in view of easiness and reliability of formation of fine unevenness structure.